

THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of:

Ramsbey, et al.

Serial No.: 09/430,366

Filed: October 28, 1999

For: Method Of Making A Memory Cell With Polished Insulator Layer Art Unit: 2813

Examiner: Chen, Jack S. J.

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**RESPONSE TO FINAL OFFICE ACTION** 

Mail Stop AF Honorable Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir/Madam:

This is in response to the *Final Office Action* dated November 14, 2003 in the above-referenced patent application. Please enter and consider the following remarks.